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# Kinetics of monolayer and bilayer nanoparticle film formation during electrophoretic deposition

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The kinetics of electrophoretic deposition are studied for the growth of monolayers and bilayers of  $\sim 10$  nm iron oxide nanoparticles. The net deposited nanoparticle film is measured as a function of time for five voltages through analysis of scanning electron microscopy images of the films. The collected data suggest that films deposited at different voltages have different kinetic behaviours. Additionally, we observe monolayer and bilayer growth separately, from which we assert that the initiation of the bilayer may be the source of variation in kinetic behaviour.

**Keywords:** Electrophoretic deposition, Directed assembly, Iron oxide, Monolayer, Time-resolved

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## Introduction

Electrophoretic deposition (EPD), a versatile, scalable, and rapid process used to fabricate thin films from colloidal suspensions, is an attractive materials casting approach for industrial applications.<sup>1–8</sup> However, the utility of EPD could be dramatically enhanced if a more complete model that describes EPD was to exist. Some models exist that attempt to predict the amount of deposition as a function of time.<sup>9,10</sup> Additionally, functional forms have been found to fit the electrophoretic current profile measured during deposition using a constant voltage.<sup>11</sup> The vast majority of these models involve the EPD of materials suspended in polar solvents, which have notably different kinetics from that of nonpolar solvent suspensions, such as those employed in this study.<sup>9,12</sup> A few studies have examined the notable characteristics of the deposition kinetics of nonpolar solvent EPD.<sup>11,13</sup> However, no model currently exists that satisfactorily describes the EPD process in nonpolar solvent environments.

In this article, we are motivated to execute the initial component of an (semi-)empirical model of the time-resolved deposition of nanoparticles by EPD. We present experiments to measure the time dependence of the quantity of deposition for different deposition voltages. Two aspects of the EPD system used in this

study engender simple conditions that should facilitate the development of such an EPD model. First, we used nonpolar solvents to suspend the nanoparticles.<sup>11,14–16</sup> By using nonpolar solvents, we eliminate many of the complexities encountered when using polar solvents, such as electrohydrodynamic flows and electrolysis.<sup>17,18</sup> Second, we can easily deposit monolayer and bilayer nanoparticle films.<sup>11,14,15,19</sup> By using such thin films of nanoparticles, we can ignore the resistive and capacitive effects the film has on the current profile of the system.<sup>9</sup> These simplifications establish an appropriate and reasonable starting point for the development of an EPD model.

## Experimental

Iron oxide nanoparticles were synthesised using previously described procedures.<sup>14,16,20</sup> The nanoparticles were suspended in hexane at a concentration of  $0.1 \text{ mg mL}^{-1}$ ; the suspension preparation was facilitated by centrifugation based cleanings.<sup>11,21</sup> The particle size was measured to be  $9.8 \pm 0.9 \text{ nm}$  under transmission electron microscopy using a Phillips CM20 operating at 200 kV (Fig. 1a). The nanoparticle films were deposited onto rectangular, epi-ready, doped Si wafers that act as the field-emitting substrate during EPD (Fig. 1b). The wafers, cut to a size of  $3.5 \times 0.9 \text{ cm}$ , were mounted in parallel plate capacitor configuration with a 5 mm gap. The wafers were then inserted  $\sim 2.8 \text{ cm}$  into the nanoparticle suspension (Fig. 1c). After insertion, a voltage was applied across the two substrates. Then, the substrates were extracted from the suspension in  $\sim 5 \text{ mm}$  segments in a stepwise manner. These stepwise extractions occurred after 10, 32, 100, 316 and 1000 s of deposition, corresponding to the first time step through the fifth time step respectively (Fig. 1d). The final extraction completely removed the wafers from the NP suspension. The voltage remained on for 60 s while the suspension

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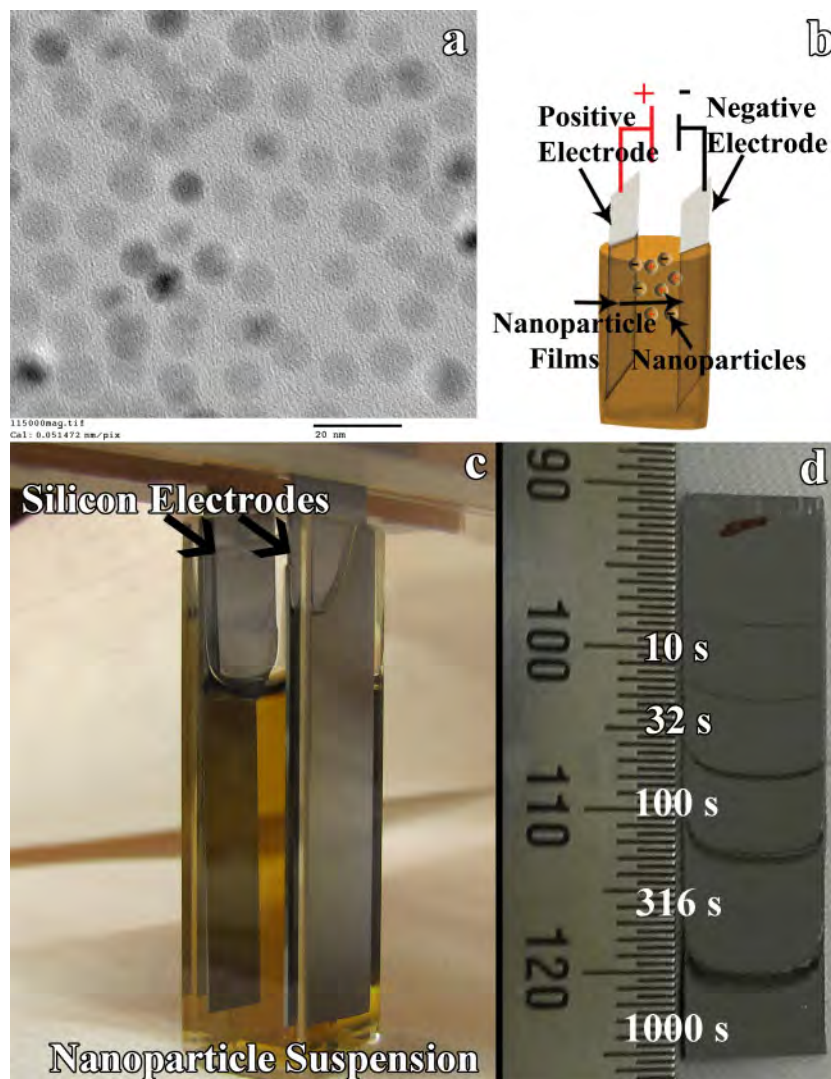
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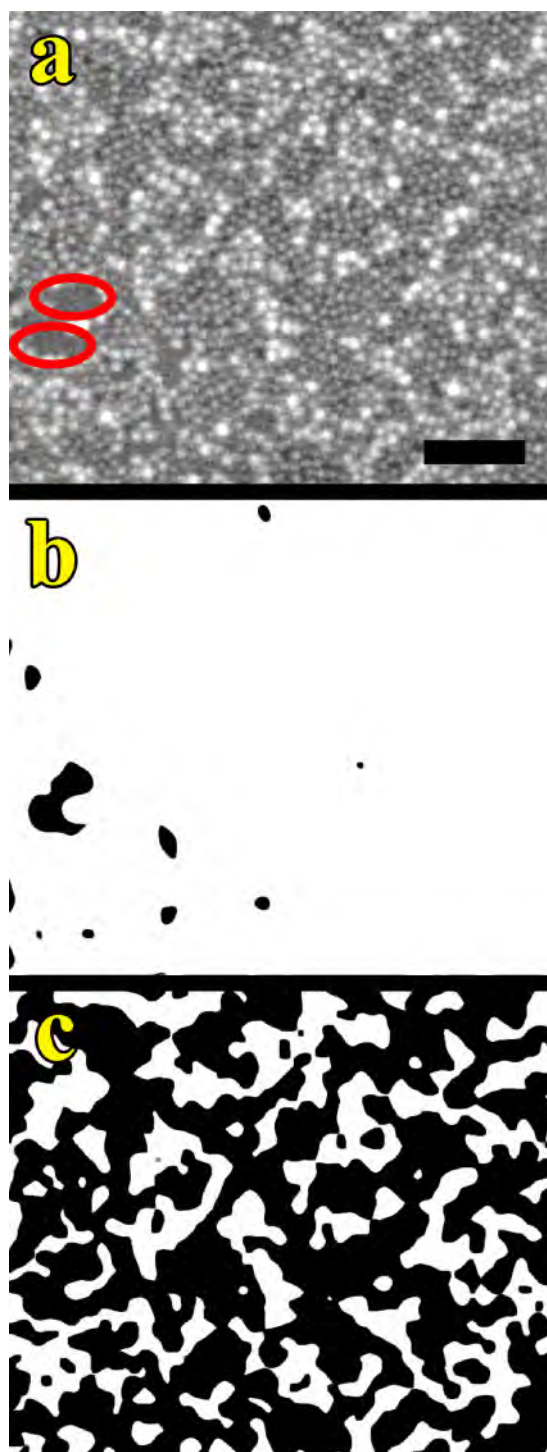
**1** *a* transmission electron microscope image of iron oxide nanoparticles. *b* schematic of electrophoretic deposition system. *c* image of execution of EPD experiment. Long silicon electrodes were inserted into a tall, glass container filled with the iron oxide nanoparticle suspension. *d* photograph that shows wafer after deposition. The dark lines that divide the regions are left by the meniscus during deposition. The wafer is labelled at the top as the negative electrode. The labelled scale is in millimetres

completely evaporated from the surface.<sup>7,22–24</sup> The above procedure was performed for five voltages chosen on a logarithmic scale: 1, 3·16, 10, 31·6 and 100 V; these correspond to applied electric fields of 2, 6·32, 20, 63·2 and 200 V cm<sup>-1</sup>.

After the deposition, the films were imaged using scanning electron microscopy (SEM). The SEM images reveal three thicknesses of deposition: bilayer thickness, monolayer, and no deposition (voids).<sup>19</sup> To discern among the three components of this film (the substrate, the monolayer and the bilayer), we performed an analysis of the image by segmenting the image into distinct regions into which the locations of each nanoparticle were mapped. This image segmentation process was performed by applying a series of image processing filters to each SEM image. An explicit description of the details of this analytical process, which the authors developed and which is beyond the scope of this article, can be found elsewhere.<sup>21</sup>

Figure 2*a* shows an image of the nanoparticle film that is representative of the samples that were acquired.

The darkest regions of this image correspond to bare silicon regions on the sample. Said regions of the silicon substrate can be perceived in very small voids between nanoparticles in the first monolayer as well as in a region, highlighted by the red ovals (a larger bare region). The majority of the SEM image comprises the first monolayer of the film, seen as grey-scaled, spherically contoured shapes (and the resulting segmented images). The bilayer in the image was represented by the brightest spherical shapes. Figure 2*b* depicts regions within the monolayer that consist of voids whose dimensions are larger than the diameter of one nanoparticle. These voids were indicated as black regions, whereas the white regions represent the extant monolayer. Figure 2*c* distinguishes the bilayer (white regions) from the monolayer and voids (black regions). The bilayer was surmised based on the increased intensity that the bilayer nanoparticles exhibited under the SEM imaging conditions. Utilising both segmented images, we compiled a complete map of the three distinct regions within the film.



2 **a** image (SEM) taken of the 100 V sample after 1000 s of deposition. Two large voids are highlighted by red ovals, which encircle them. Scale bar=100 nm. **b** image that displays the result of the monolayer segmentation. White regions are monolayers, whereas black regions are voids in the film. **c** image that displays the result of the bilayer segmentation. White regions represent where the bilayer is located, black regions represent both the monolayer and the voids. By adding the number of white pixels in both images, and dividing by the total number of pixels in one of the images, we obtain the fractional surface coverage for the film<sup>21</sup>

After segmenting the images, the fractional surface coverage (fsc) was calculated from the sum of (i) the total number of pixels in the image identified as corresponding to nanoparticles within both the monolayer and bilayer ( $\text{pixel}_{\text{m\&b}}$ ) and (ii) the total number of pixels in the image identified as corresponding to nanoparticles within the bilayer ( $\text{pixel}_{\text{b}}$ ), divided by the total number of pixels within the image ( $\text{pixel}_{\text{total}}$ )

$$\text{fsc} = \frac{(\text{pixel}_{\text{m\&b}}) + (\text{pixel}_{\text{b}})}{(\text{pixel}_{\text{total}})}$$

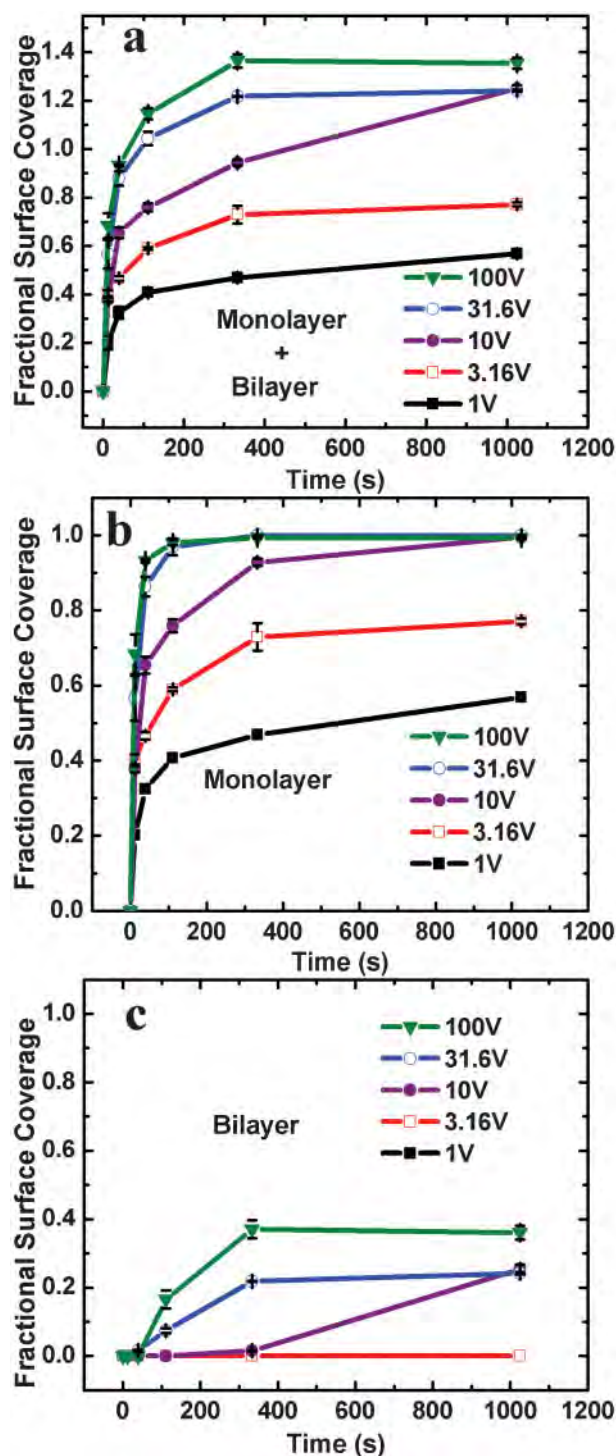
The average and the standard deviation of the fractional surface coverage, measured from the five images acquired for each voltage and time, were used as the average value and measurement error respectively. Ultimately, fsc can be interpreted as the fraction of the surface that is densely covered by nanoparticles, such that no space exists for additional nanoparticles to deposit. To be clear, fsc does not imply the fraction of the rectilinear surface area that is covered by the spherical nanoparticles, the value of which is limited to ~91% of total coverage based on hexagonally packing of circles in two dimensions. We do mean the surface area that is occupied by the nanoparticles, presuming hexagonal close packing. For example, if nanoparticle film completely covers a substrate, hence forming a monolayer, we would assert that the substrate would be 100% covered. Therefore, the fsc would be 1.0. If a monolayer has formed and a fraction of a bilayer has formed atop the monolayer, say at a fraction of 40%, the fsc would be 1.4  $\text{fsc} = \frac{1.0 + 0.4}{1.0} = 1.4$

## Results and discussion

We plotted the fractional surface coverage versus time for the five different voltages measured (Fig. 3a). Starting with the 100 V curve, we see that the deposition occurs very rapidly in the beginning. Then, the deposition rate decreases with the deposition ceasing after the fourth time step (316 s). The 31.6 V curve behaves similarly; however, the data indicate that some nanoparticles may still be depositing after 316 s. The 31.6 V sample contains less overall deposition than the 100 V sample, and the results for the 1 and 3.16 V samples also indicate that the deposition begins rapidly and the rate decreases rapidly. Apparently, the nanoparticles continue to deposit during the entire deposition, as the increase in the fractional surface coverage persisted through the experiment.

Finally, we focus more attention on the 10 V sample. The 10 V sample begins similarly to all the other samples; yet, the deposition continues at a high rate even after the fourth time step and deposits just as much as the 31.6 V sample. We investigate this further by separately plotting the growth of the monolayer and the growth of the bilayer (Fig. 3b and c). In the 10 V sample, the monolayer appears to be completely covering the surface sometime between 136 and 1000 s. The initial components of the bilayer form slowly prior to the 316 s point. Between the fourth and fifth time steps, the deposition of the bilayer markedly increases. Possibly, the completion of the monolayer induces the rapidity of growth of the bilayer. We speculate that when the initial monolayer nears completion, nanoparticles





3 a graph of the total fractional surface coverage, fsc, including the coverage comprised by the bilayer and monolayer. Deposition associated with the 100 and 31.6 V samples ceased almost entirely after 316 s. The 10 V sample, deposition continues rapidly during the deposition. b graph that displays the surface coverage from the monolayer only. The 100, 31.6 and 10 V samples all form complete monolayers. c graph that displays the surface coverage from the bilayer only. The 10 V sample bilayer grows rapidly after 316 s of deposition. The bilayer of the 100 and 31.6 V samples nearly ceases to grow after 316 s

must search for and identify sites on which to deposit. After the monolayer is complete, bilayer particles initially deposit at any location on the surface; thus, they deposit

rapidly initially. A time-resolved study (for example with  $\leq 10$  s intervals) could yield sufficient information to corroborate or to disprove our proposed model. Finally, we note that the bilayer growth does not begin in any of the samples until the fractional surface coverage is  $\sim 85\%$ . For the two highest voltages, bilayer growth does not occur until after the first time step. Bilayer growth also does not occur at all in the two lowest voltages. This is consistent with previously observed layer-by-layer growth of monolayer films by EPD.<sup>14</sup>

## Conclusion

The fractional surface coverage versus time curve shown herein provide useful information that could be utilised to test the efficacy of EPD models. Thus, we find that the poor time resolution of experiments, such as the one described herein, limits the level of information that can be extracted about the deposition. We envision two possible solutions to the limitations imposed by poor time resolution. First, *in-situ*, 'direct' measurements on the amount of deposition could be done utilising tools, such as an electrochemical quartz crystal microbalance or X-ray scattering measurements. Another possible route to increasing time resolution and repeatability is by acquiring *in-situ*, 'indirect' measurements on the amount of deposition. Measurements, such as suspension concentration versus time that could be determined from absorption measurements, or the current density versus time could be used as indirect measurements. These measurements could then be related to the amount of deposition either by theory or empirical data.

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